

## Patent Assignment Abstract of Title

**Total Assignments: 1****Application #:** 10070996**Filing Dt:** 03/14/2002**Patent #:** NONE**Issue Dt:****PCT #:** NONE**Publication #:** NONE**Pub Dt:****Inventors:** Tatsuro Kato, Tomoaki Utsumi, Fumihiro Endo, Kazuo Kobayashi, Kazuhiro Saito**Title:** Gas insulated device and failure rating method**Assignment: 1****Reel/Frame:** 012918/0298 **Received:** 05/28/2002 **Recorded:** 05/21/2002 **Mailed:** 07/24/2002 **Pages:** 2**Conveyance:** ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).**Assignors:** KATO, TATSURO**Exec Dt:** 03/06/2002

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